

Docket No. 241280US2S DIV
 IN RE APPLICATION OF: Tsutomu SATO et al.
 SERIAL NO: 10/637,665
 FILED: August 11, 2003
 FOR: SEMICONDUCTOR DEVICE FORMED IN SEMICONDUCTOR LAYER ARRANGED ON SUBSTRATE
 WITH ONE OF INSULATING FILM AND CAVITY INTERPOSED BETWEEN THE SUBSTRATE AND THE
 SEMICONDUCTOR LAYER



"RESPONSE UNDER 37 CFR 1.116-
 EXPEDITED PROCEDURE EXAMINING
 GROUP 2818"

AF
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COMMISSIONER FOR PATENTS
 ALEXANDRIA, VIRGINIA 22313

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SIR:

Transmitted herewith is an amendment under 37 C.F.R. § 1.116 in the above-identified application.

No additional fee is required
 Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
 Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	3	MINUS	20	0	x \$50 =	\$0.00
INDEPENDENT	1	MINUS	3	0	x \$200 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$360 =	\$0.00
						TOTAL OF ABOVE CALCULATIONS
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
						TOTAL
						\$0.00

A check in the amount of \$0.00 is attached.
 Credit card payment form is attached to cover the fees in the amount of \$0.00
 Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
 If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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DOCKET NO: 241280US2S DIV



"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 2818"

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

TSUTOMU SATO ET AL.

: EXAMINER: NGO, N. V.

SERIAL NO: 10/637,665

:

FILED: AUGUST 11, 2003

: GROUP ART UNIT: 2818

FOR: SEMICONDUCTOR DEVICE
FORMED IN SEMICONDUCTOR
LAYER ARRANGED ON
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AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 3, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.